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In Re Application of: Divakaruni et al.

Conf. No.: 1387

Serial No.: 10/707,388

Art Unit: 2891

Filed: 12/10/2003

Dkt. #: FLS920030274US1 (IBMF-0032)

Title: SILICIDE RESISTOR IN BEOL
LAYER OF SEMICONDUCTOR
DEVICE AND METHOD

Examiner: Fulk, Steven J.

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Response to Restriction Requirement in 5 pages

in the above identified application.

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

I. INTRODUCTORY COMMENTS

This paper is being filed in response to the Restriction Requirement dated June 9, 2005.

Applicant hereby provisionally elects Group III, claims 12-20, with traverse.